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(54) **Hole transport material and method of manufacturing the hole transport material**

(57) In an organic EL device, when a voltage is applied across an anode and a cathode, holes are moved in a hole transport layer and electrons are moved in an electron transport layer, and the holes and the electrons are recombined in a light emitting layer. In the light emitting layer, excitons are produced by energy released upon the recombination, and the excitons release energy in the form of fluorescence or phosphorescence or emit light when returning to the ground state. The hole transport material is used in the hole transport layer, in which the amount of cationic impurities and/or the amount of anionic impurities are controlled to be small, so that the decrease of light-emission luminance of the organic EL device is suppressed and excellent light emitting properties are maintained for a long period of time.

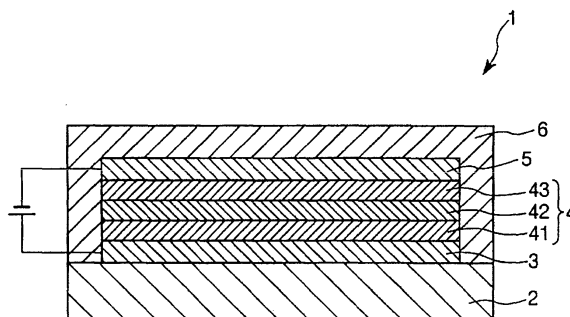


Fig. 1



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1 The present search report has been drawn up for all claims			
Place of search The Hague		Date of completion of the search 18 April 2005	Examiner Wolfbauer, G
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The present search report has been drawn up for all claims			
Place of search The Hague		Date of completion of the search 18 April 2005	Examiner Wolfbauer, G
CATEGORY OF CITED DOCUMENTS X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document		T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document	

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ANNEX TO THE EUROPEAN SEARCH REPORT
ON EUROPEAN PATENT APPLICATION NO.

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This annex lists the patent family members relating to the patent documents cited in the above-mentioned European search report. The members are as contained in the European Patent Office EDP file on
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专利名称(译)	空穴传输材料和制造空穴传输材料的方法		
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其他公开文献	EP1482576A2		
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摘要(译)

在有机EL器件中，当在阳极和阴极之间施加电压时，空穴在空穴传输层中移动并且电子在电子传输层中移动，并且空穴和电子在发光层中复合。在发光层中，激子由重组时释放的能量产生，并且激子以荧光或磷光的形式释放能量或当返回基态时发光。空穴传输材料用于空穴传输层，其中阳离子杂质的量和/或阴离子杂质的量被控制得很小，从而抑制了有机EL器件的发光亮度的降低。长时间保持优异的发光性能。

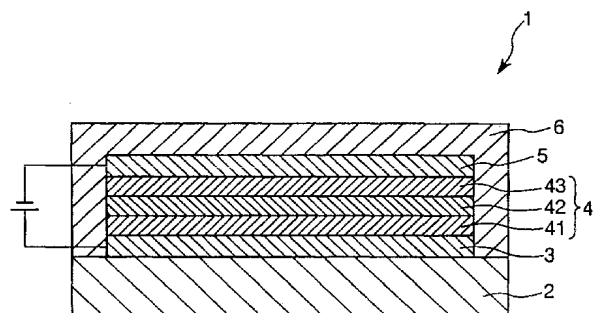


Fig. 1